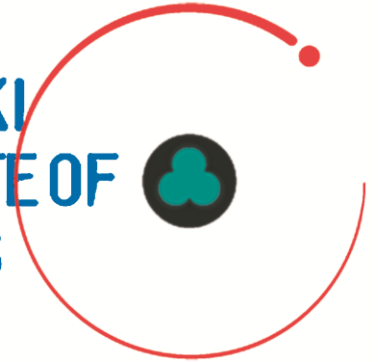




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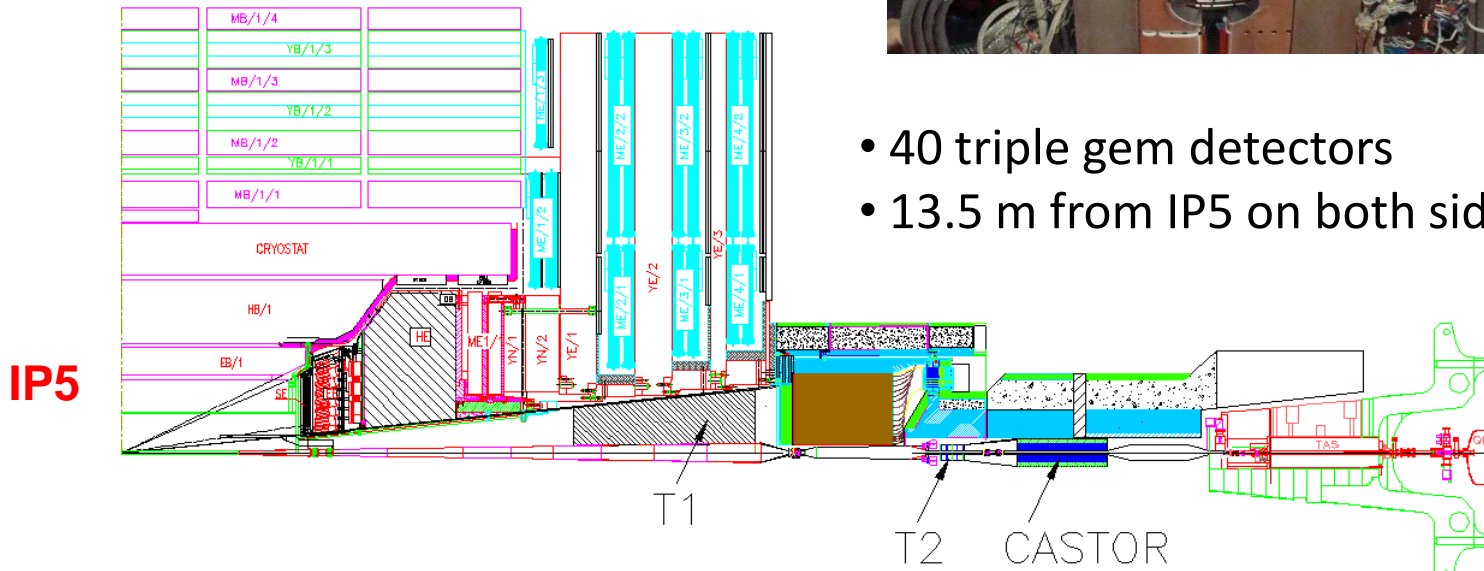
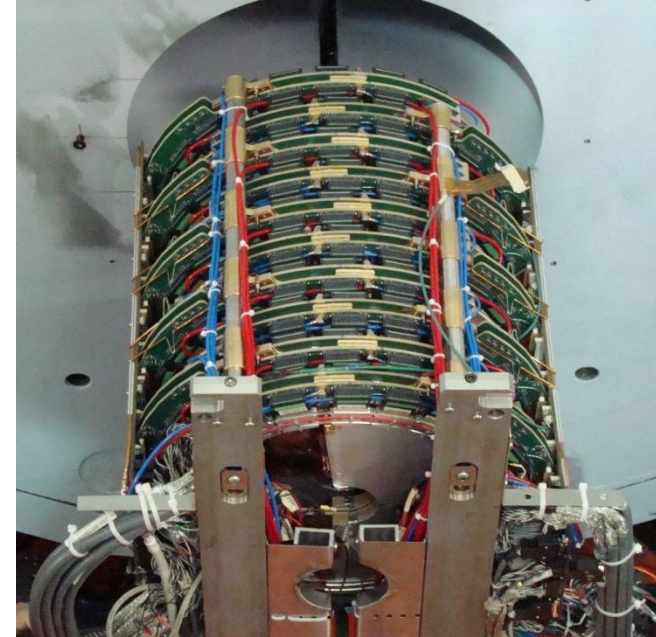
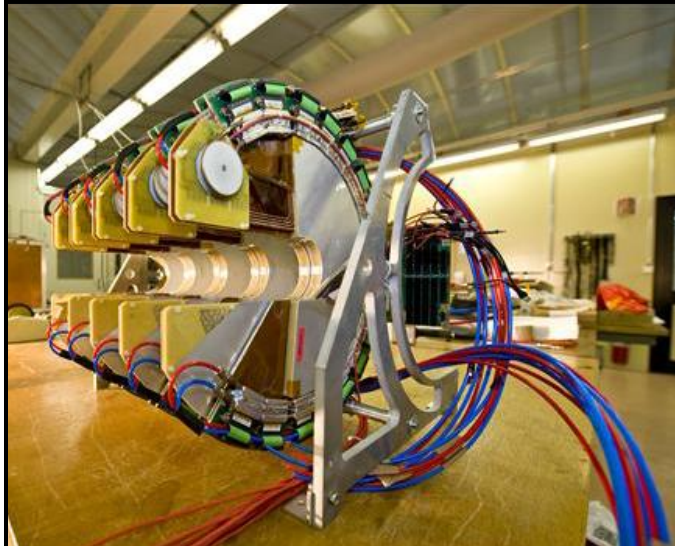


# Quality assurance of TOTEM T2 GEM detectors

Timo Hildén

Helsinki Institute of physics

# Totem T2

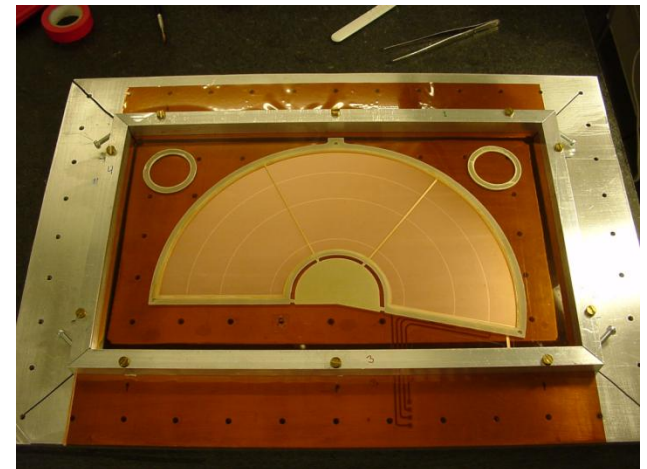
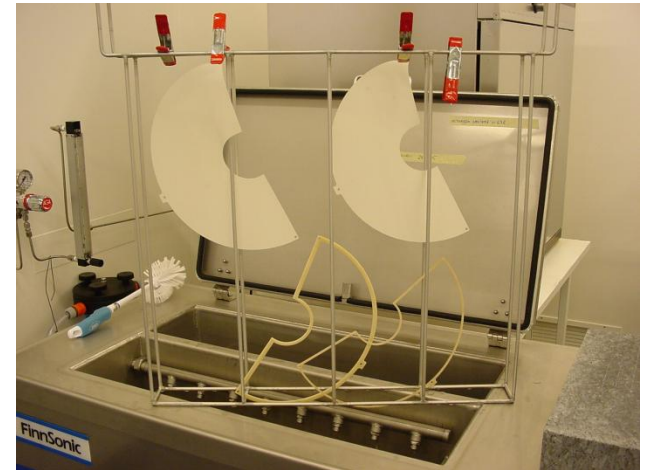


# Assembly

- Big production for Detector Laboratory in Helsinki
- Focus in cleanliness of the process
- Full production line was set up in a class 1000 cleanroom prior assembly. Foils were mostly handled in class 100 cleanroom
- Storage of gem foils and readout boards in dry nitrogen atmosphere

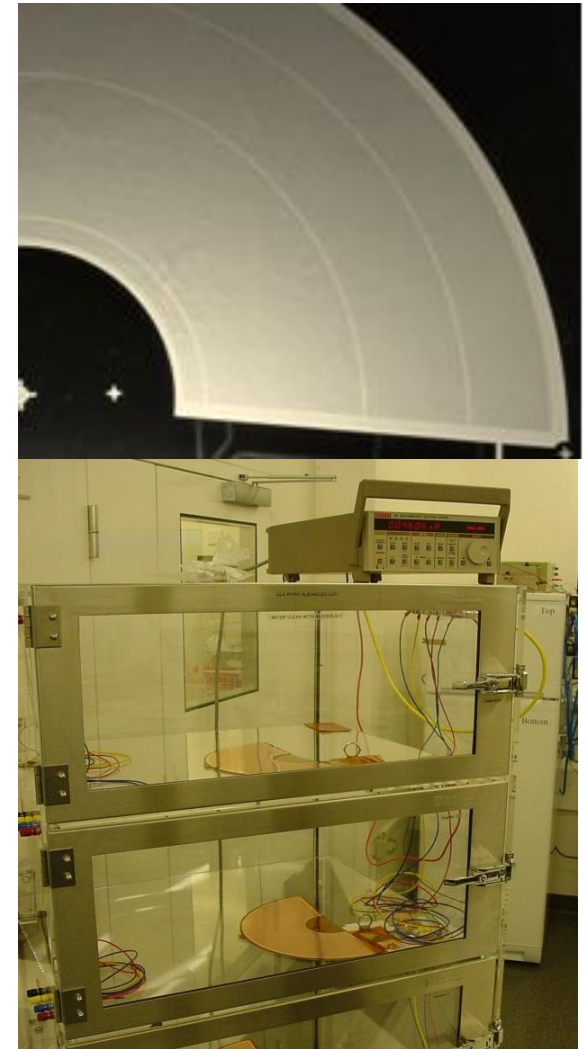
# Frames

- Cleaning in ultrasonic bath
- Fibers sticking out from the frames after machining - Nuvovern coating
- High voltage tests with 5000 V after Nuvovern treatment
- Foils were stretched with a special stretcher for framing
- Foil tension samples taken occasionally on ring-like frames

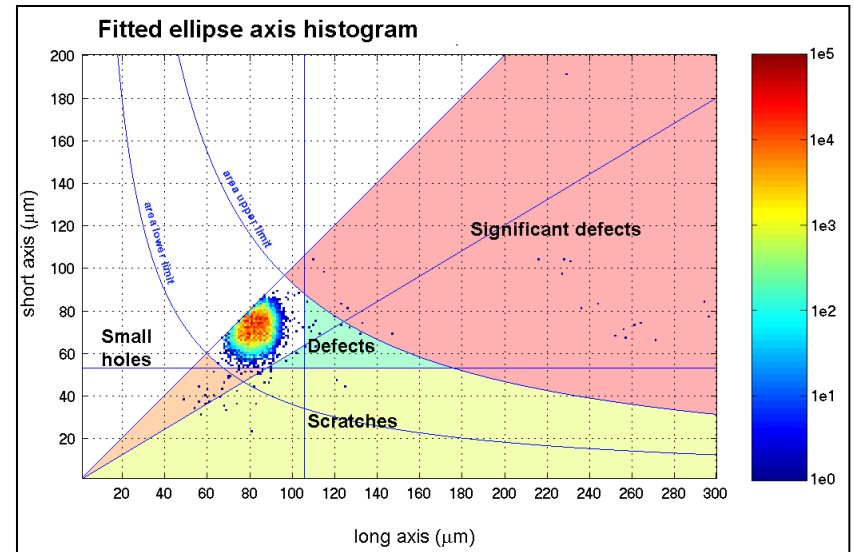


# Foils

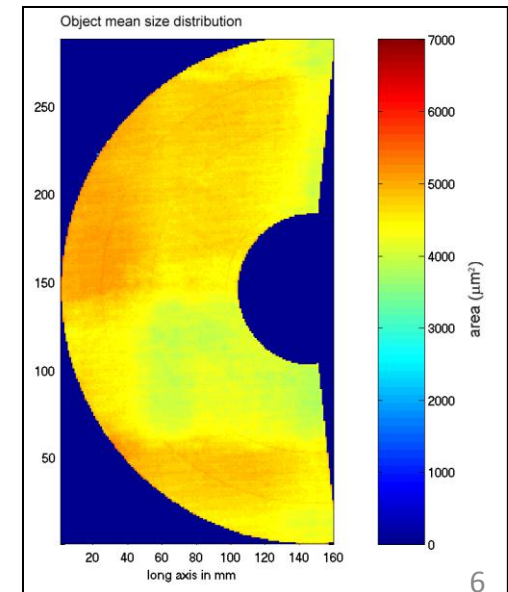
- Gem foil leakage currents were tested in 3 phases of the assembly: Upon arrival, after framing and once the stack was glued together – 36 measurements per detector
- Measurements in dry nitrogen atmosphere inside dessicator
- Approval criterion was set to  $I < 0.5 \text{ nA}$  for at least 30 minutes with 500V over the foil
- Perhaps best indicator of foil performance in the operation tests



# Foils



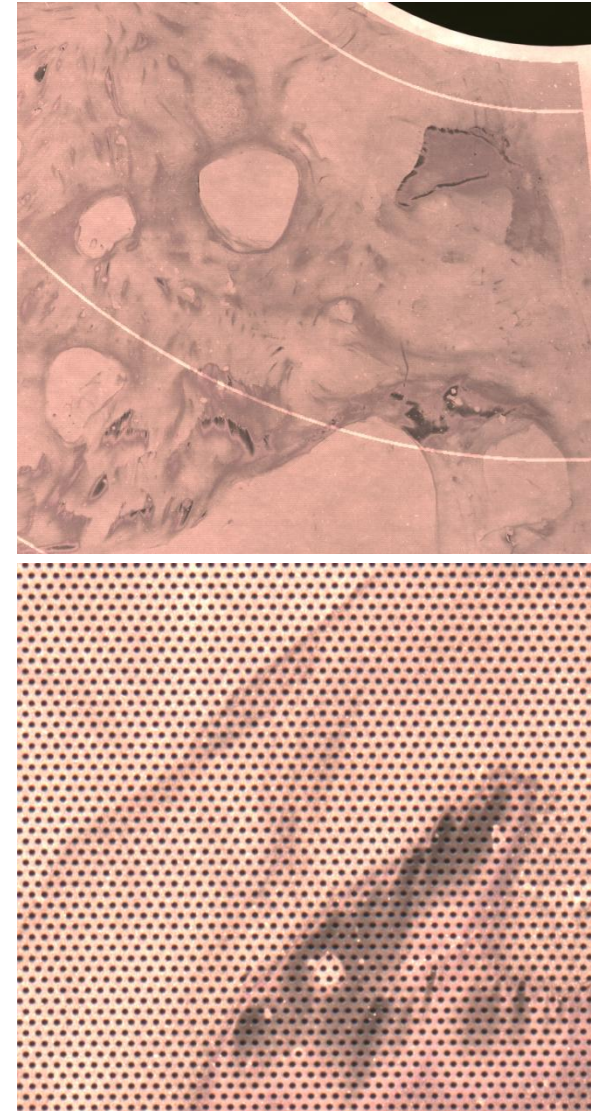
- Optical scanning method was developed utilizing Commercial flatbed scanner with blue diffuser and a background lighting setup
- scanning with resolution of 2400 dpi – pixel size  $\sim 10 \mu\text{m}$ .
- Images archived for later inspection
- more sophisticated system was developed later





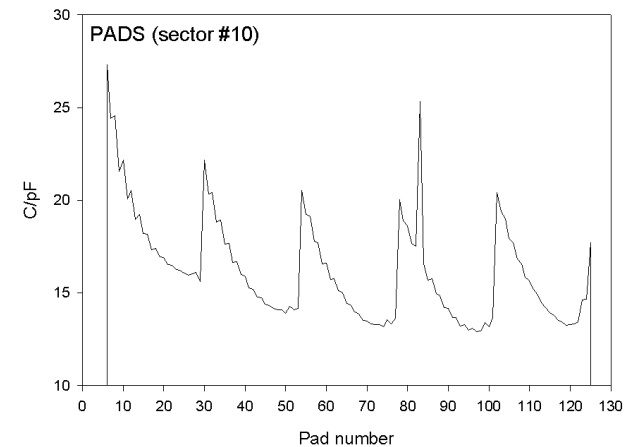
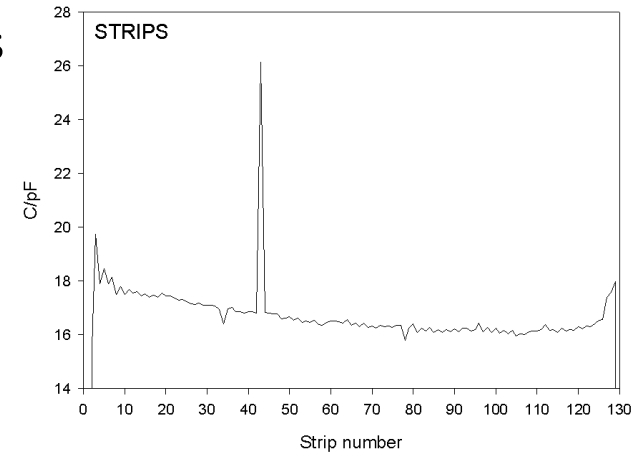
# Foils

- Few foils had a short circuit
- Some were found dirty and discarded by visual inspection only. These were sent to Cern for cleaning/passivation and recovered.
- Some shorted foils were cured in Helsinki by baking in vacuum oven for several hours.
- 6 foils out of 150 were discarded in total



# Readout boards

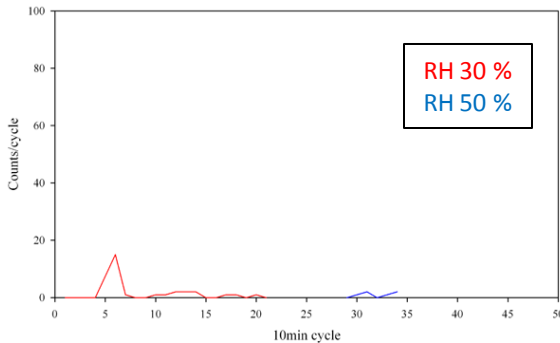
- Readout boards were tested for short circuits and broken strips/vias
- Semi automatic capacitance measurement system with LCR meter and a XYZ-table was developed
- 12 ROBs with 18 short circuits in total were found. 7 were recovered by burning the shorts
- 11 broken strips/vias on 6 ROBs were found
- 7 ROBs had problem with blocked canals for gas.
- Some ROBs had crystallized residue on the electrodes and were sent to be cleaned at Cern
- All ROBs were assembled



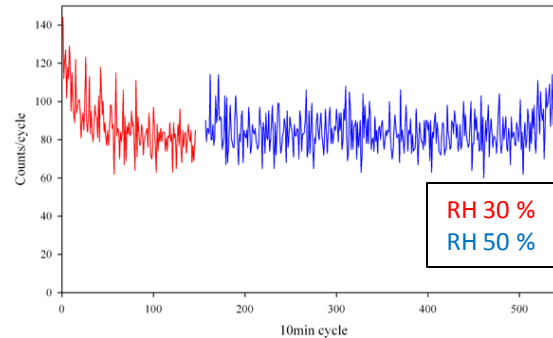


# Humidity

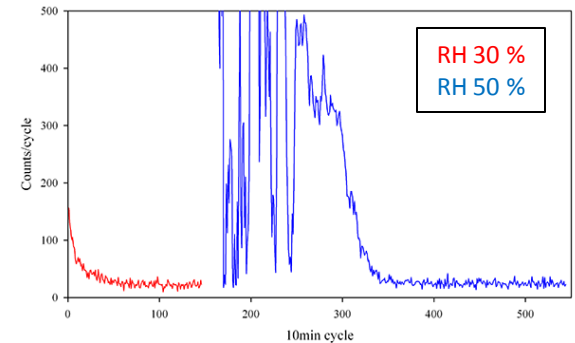
HG39, big pulses at 25°C, 4.5 kV, different humidities



HG26, big pulses at 25°C, 4.5 kV, different humidities



HG26, big pulses at 25°C, 4.5 kV, different humidities

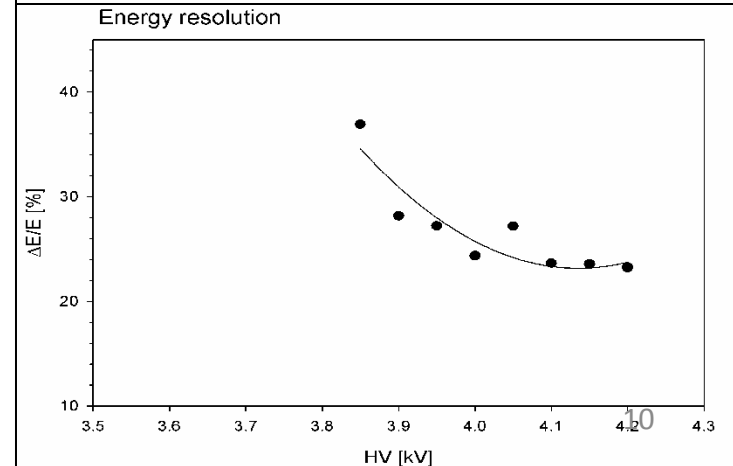
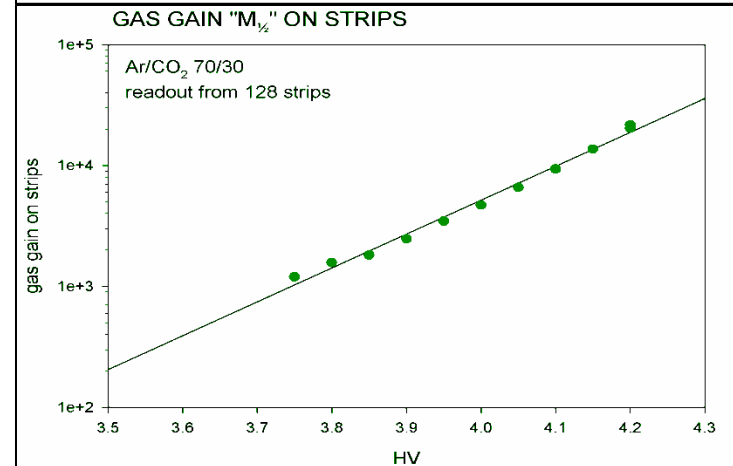
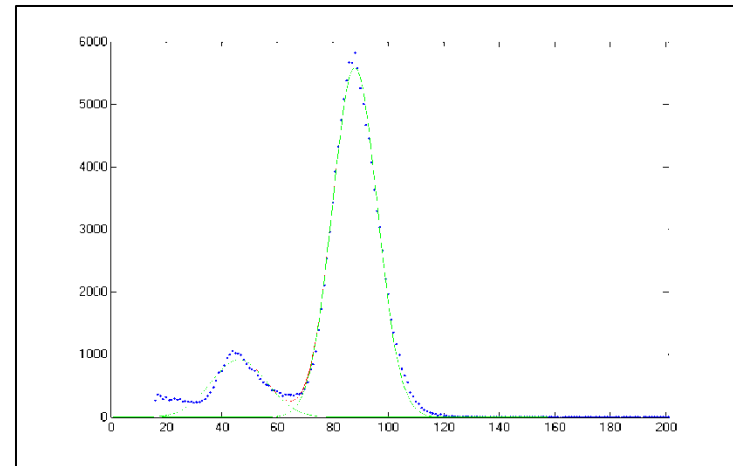


- Problems with HV system in humid conditions
- A layer of Dow Corning conformal coating was supplied over the HV board and the Polyimide HV strips outside the chamber
- Environmental chamber to test the detectors in 50% humidity with nitrogen
- Stability tested for 12 hours in 4.5 kV, eventually ramped up to 5 kV for an hour



# Operation tests

- Gain uniformity and operational stability were tested before assembling of the electronics
- Gain and resolution was tested for each sector at nominal gain of 8000 (17 sectors: 4 strips and 13 pads)
- Detectors were tested with  $^{55}\text{Fe}$  up to gain of 50000
- Irradiated with  $^{55}\text{Fe}$  at nominal gain for at least a week to ensure stable operation
- Tests with final electronics and beam tests at Cern
- RF shielding was added to enhance noise behavior
- New voltage division – increased induction field



# Assembling of a T2 GEM detector

<b>1. Sandwich</b>	- ready made by CERN	0 h	<b>10. Readout board</b>	- glued to sandwich by CERN	0 h
<b>2. Preparation of frames</b>	- cleaning/grinding	1 h		- visual inspection	1 h
	- ultrasonic cleaning	1 h		- soldering of the connectors	8 h
	- drying in oven	4 h		- capacitance measurements	4 h
	- nuvoern varnishing	½ h		- burning of the shorts	4 h ?
	- curing in oven	2 h	<b>11. Gluing the readout board to the GEM stack</b>	- gluing the gas adapters	1 h
	- HV test	½ h		- curing in oven	16 h
<b>3. GEM foils (3 pcs.)</b>	- visual inspection	1 h		- removal of the central disk of the ROB	
	- optical scanning	1 h	<b>12. Sealing the GEM</b>	- Araldite/Dow Corning	2 h
<b>4. Leakage current tests of the GEM foils</b>	- 3 foils, 12 segments in total	8 h		- curing in oven	16 h
<b>5. Framing of the GEM foils (3pcs.)</b>	- stretching and gluing	3 h	<b>13. Finishing work</b>	- assembling of the voltage divider pcb	2 h
	- curing in oven	16 h		- assembling the HV cable	1 h
	- finishin the framed foils			- connecting the gas connector	
<b>6. Leakage current tests of the framed foils</b>		8 h	<b>14. Tests</b>		5 days
<b>7. Gluing the drift foil to the sandwich</b>	- curing in oven	16 h		- gas leaks?	
				- environmental chamber, HV-tests	
				- electronic tests	
<b>8. Assembling of the GEM stack</b>	- gluing the three framed foils	2 h		<b>total:</b>	<b>2-3 weeks</b>
	- curing in oven	16 h			
<b>9. Leakage current tests of the GEM stack</b>		8 h			

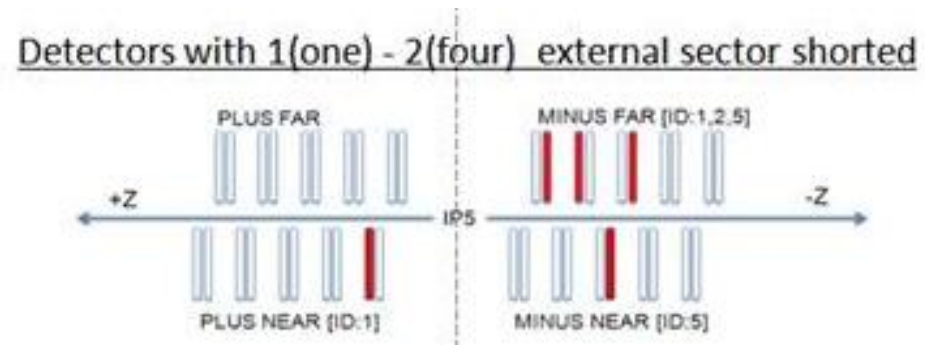
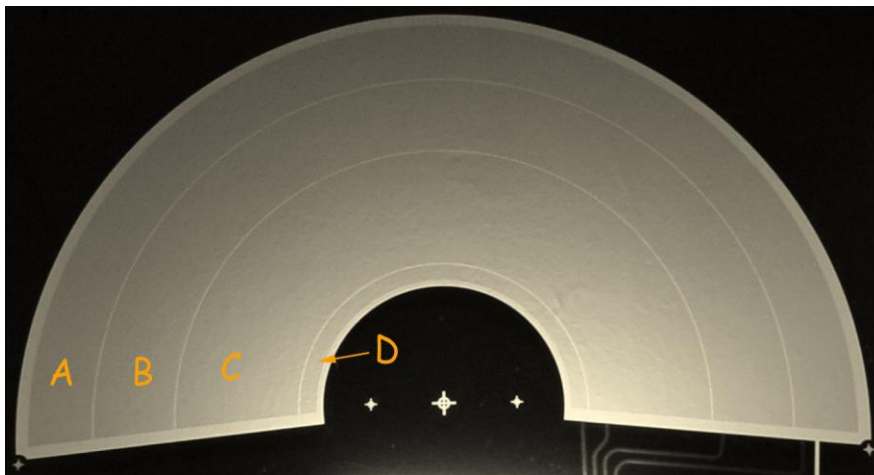
*Assuming all the components are available and storage in dry atmosphere!*

# Yield

- 6 detectors were discarded during assembly:
  - 2 had irreparable short circuits inside the chamber
  - 2 had frequent discharges at operating voltage
  - 2 had irreparable discharges outside the chamber

# Some notes on T2 performance

- Operated with huge rates down to HV system saturation, and with heavy ions runs with highly ionizing particles
- Lost sectors in 5 detectors (2 external sectors in four detectors and 1 in one) due to short circuits



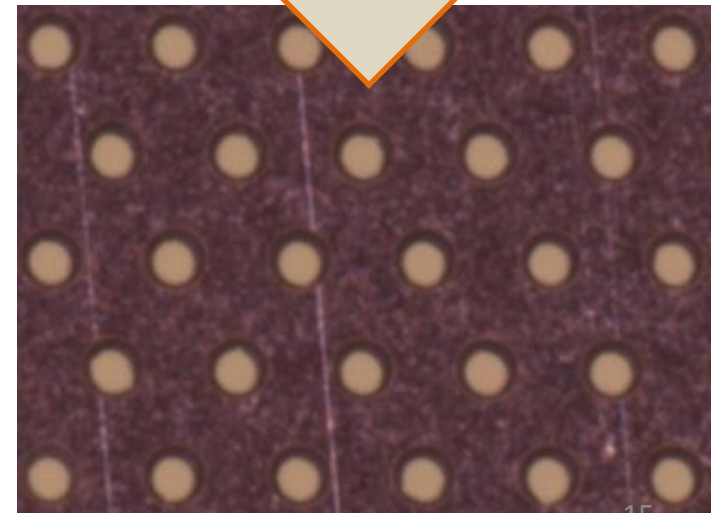
# Future

- Production of 4 FAIR TPC prototypes ongoing
- Mass production (32 detectors + spares) foreseen 2016 - 2018
- Other large scale productions?
- QA procedures will be based on T2 experience, but with the new optical scanning system



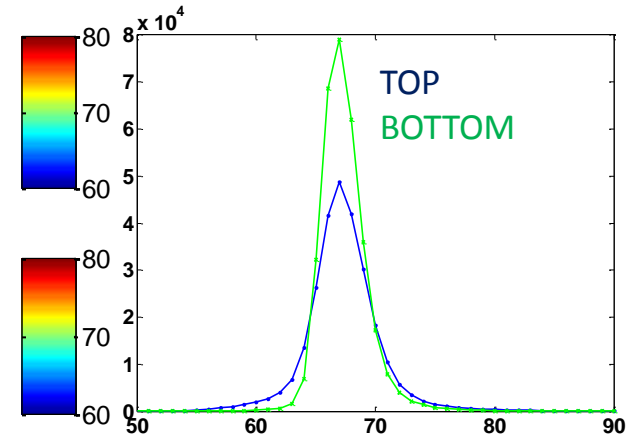
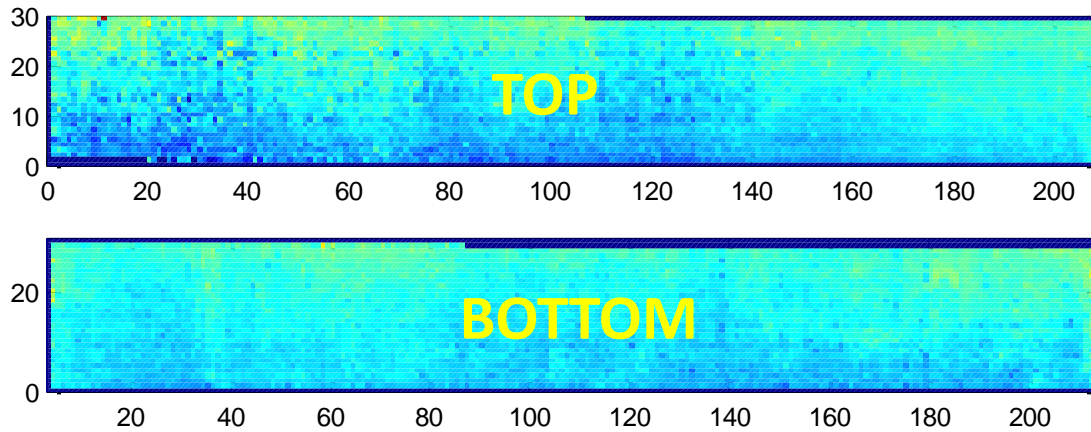
# New optical scanning system

- 98 cm x 98 cm XYZ-table with camera and telecentric objective
- Single pixel 1.75  $\mu\text{m}$  square. Resolution of 144 lp/mm – two lines can be resolved if the separation between them is 7 microns
- Analysis software with object classification and stitching of separate images
- Find etching defects, measure hole diameter, pitch etc. Useful for QA in gem detector construction
- Other measurements like hole shape or inner and outer hole alignment for QA in gem foil manufacturing?

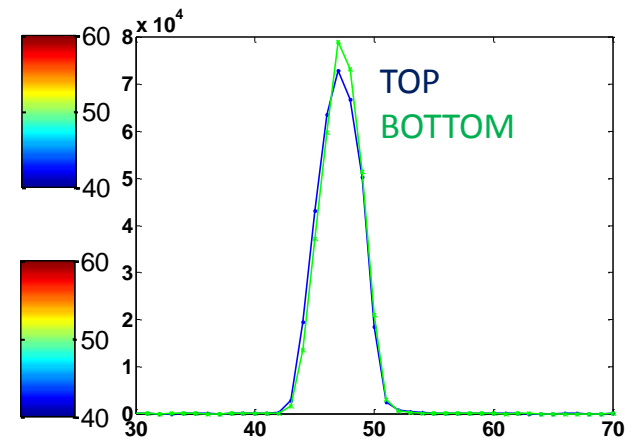
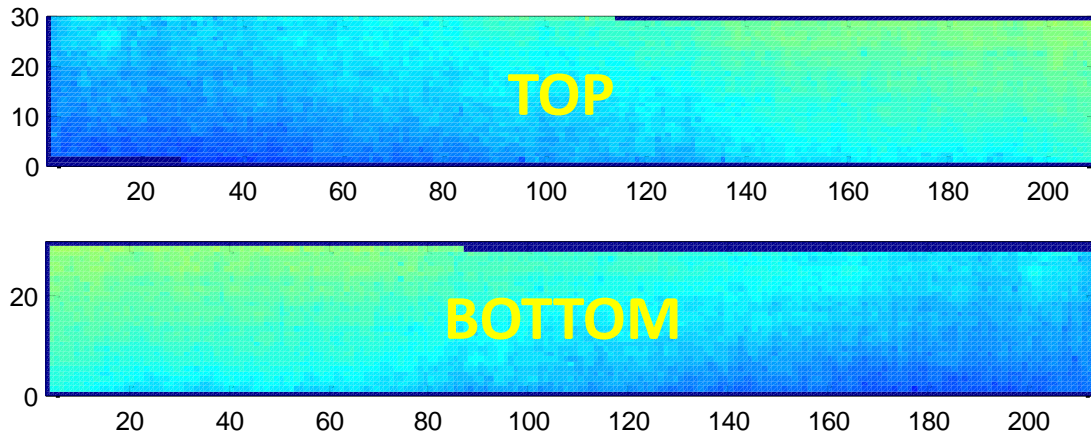


# Hole size

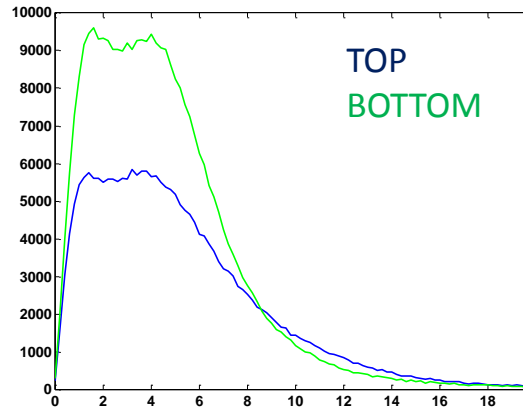
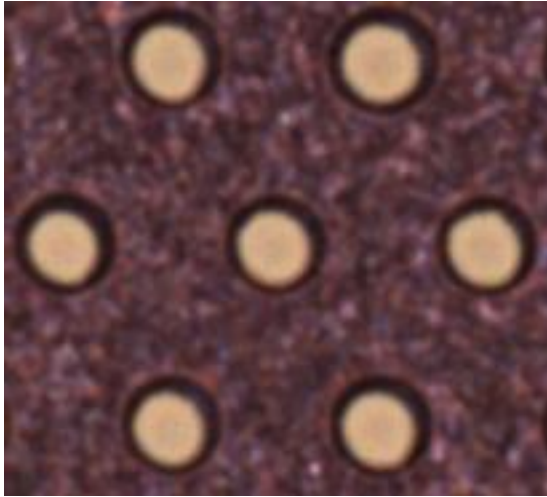
## Outer hole diameter



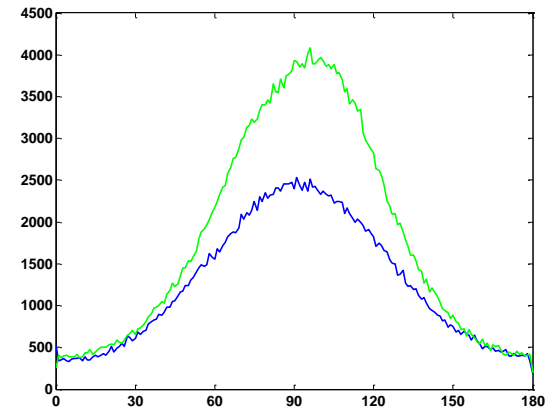
## Inner hole diameter



# Hole shape



Difference between major and minor axes [ $\mu\text{m}$ ]



Major axis angle from horizontal [Deg]

